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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirm. No.: 4687

NAKAYAMA

Atty. Ref.: 914-170

Serial No. 10687,620

TC/A.U.: 2814

Filed: October 20, 2003

Examiner: Pham, L.

For: SEMICONDUCTOR DEVICES AND METHODS OF
MANUFACTURE THEREOF

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January 10, 2007

MAIL STOP AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

Responsive to the FINAL Office Action dated September 11, 2006 (for which a one-month extension of time is hereby sought), please favorably entertain the ensuing comments in conjunction with reconsideration of the patentability of the captioned application.